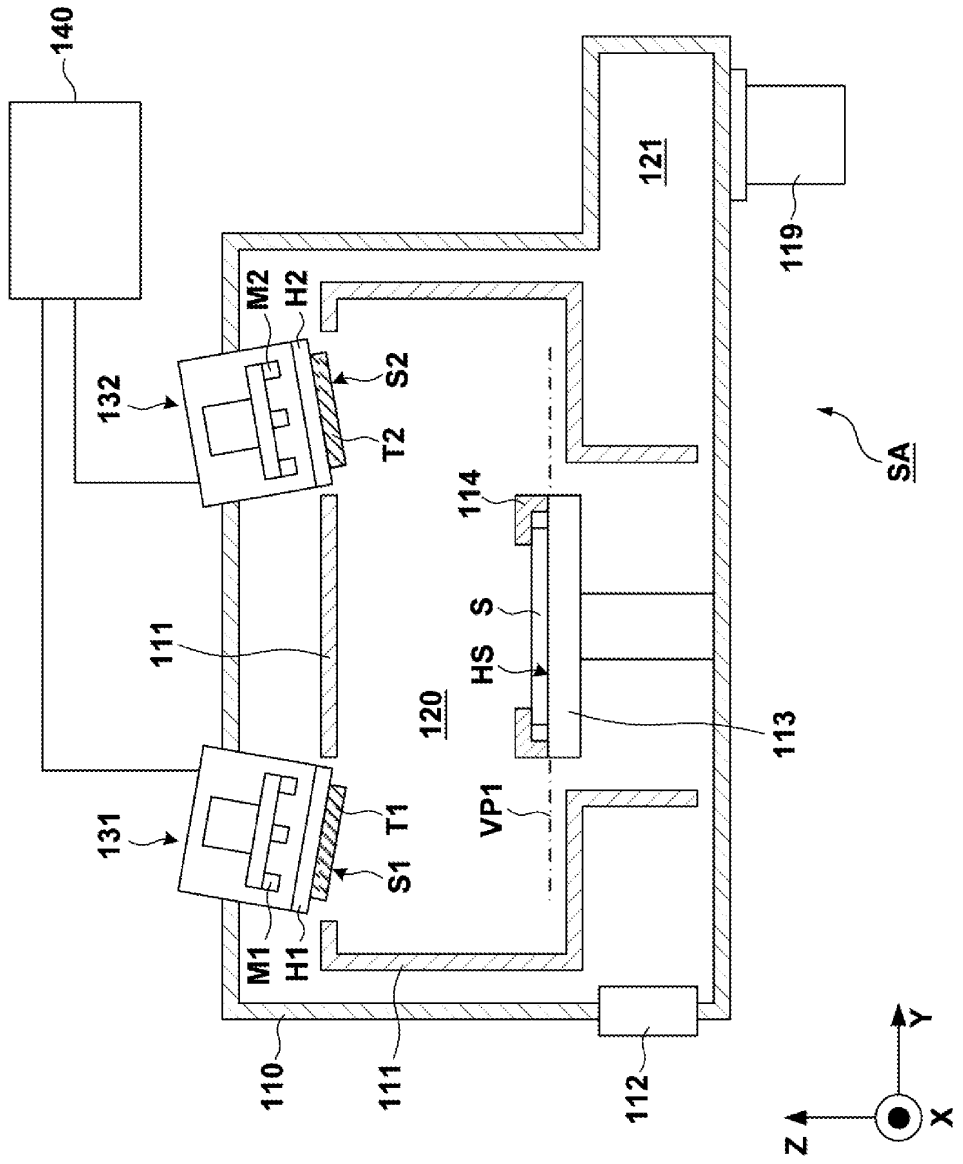
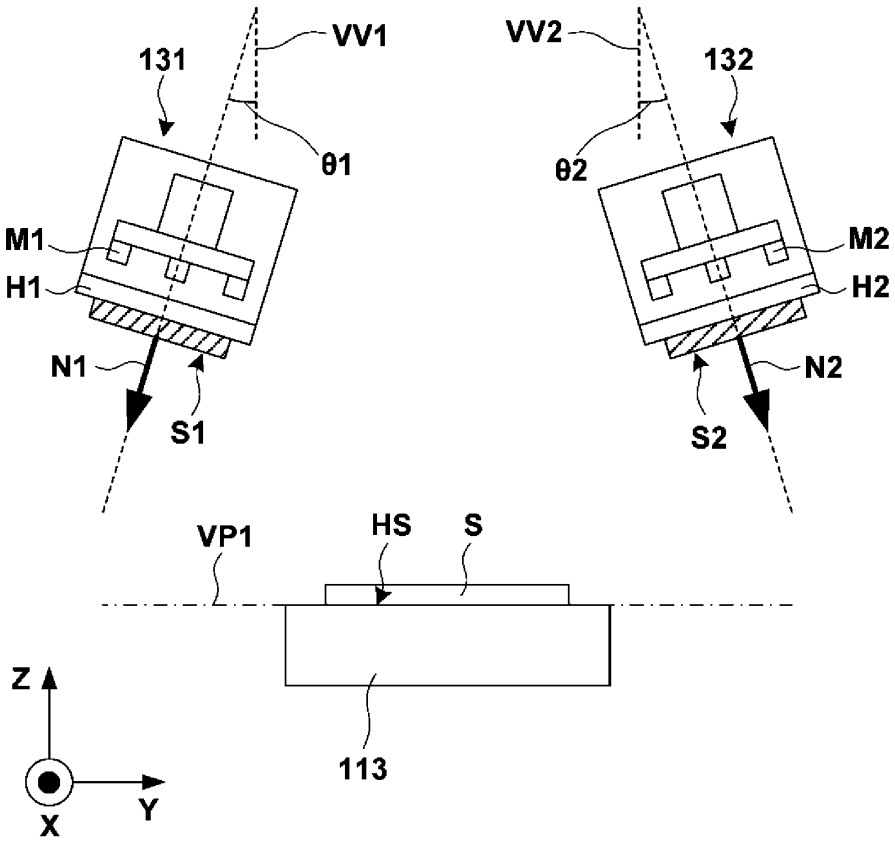
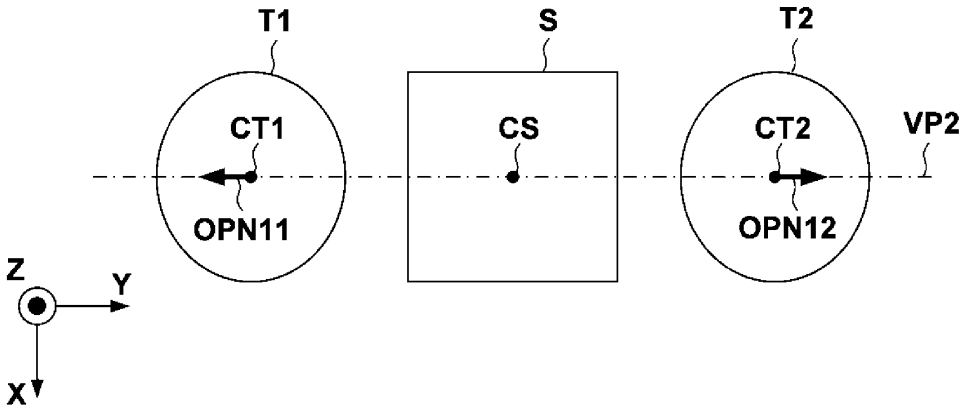
[図1]


140
121
119
M2
H2
S2
T2
132
SA
114
S
HS
111
120
113
131
T1
S1
VP1
M1
H1
110
111
112
Y
X
Z

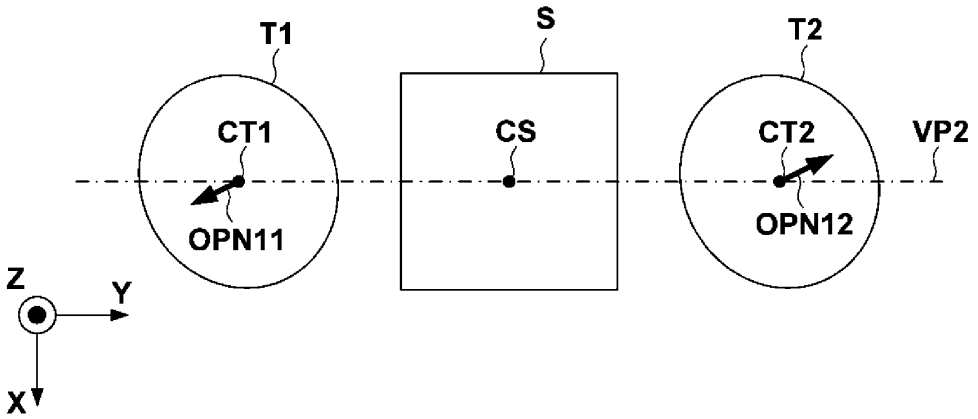
[図2]



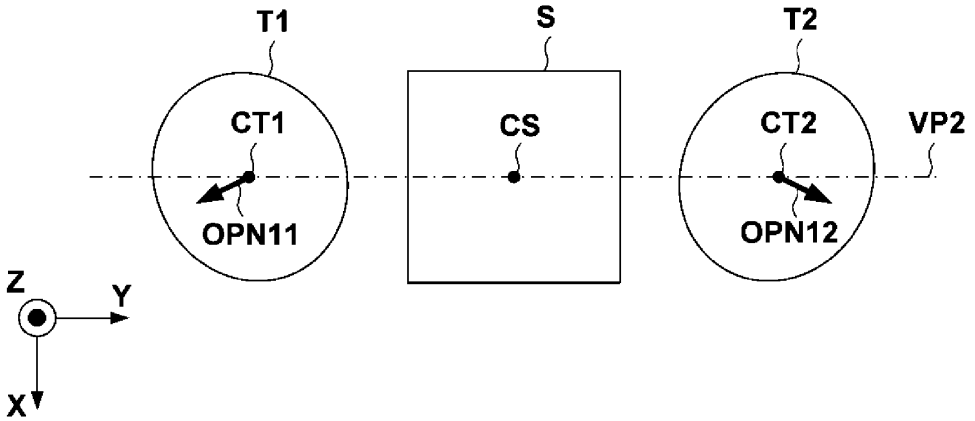
[図3]


T1
S
T2
CT1
CS
CT2
VP2
OPN11
OPN12
Z
Y
X

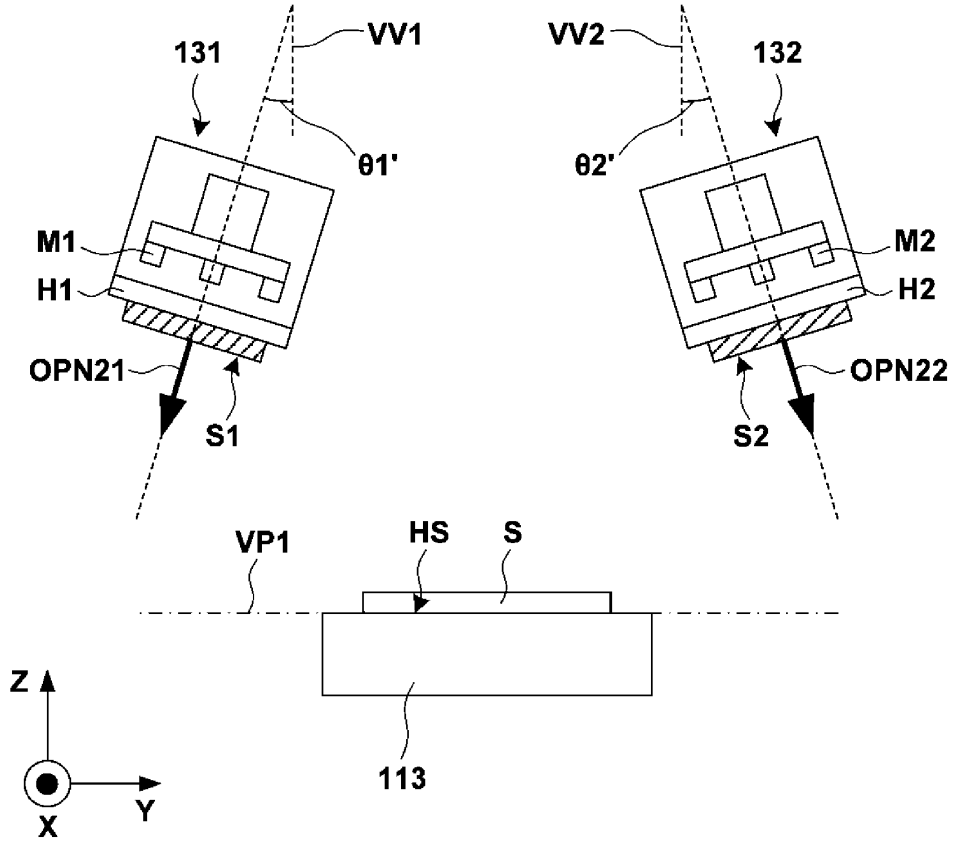
[図4]


T1
S
T2
CT1
CS
CT2
VP2
OPN11
OPN12
Z
Y
X

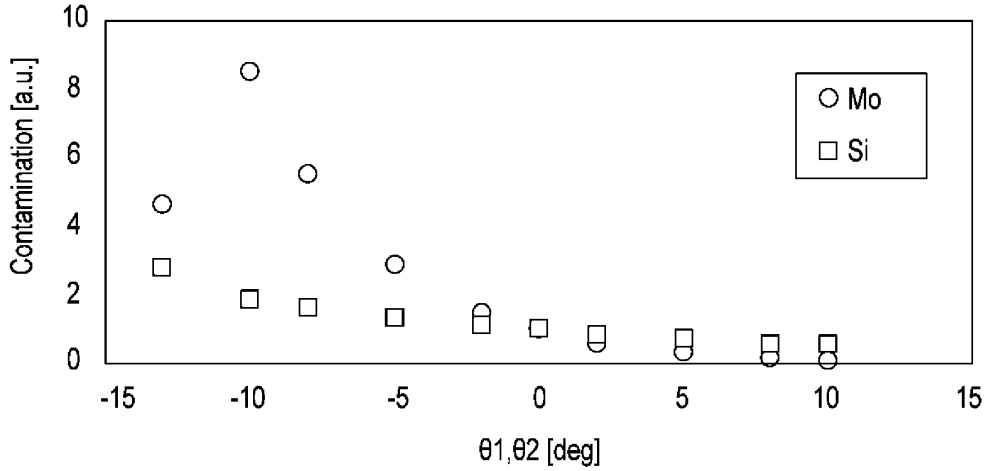
[図5]


T1
S
T2
CT1
CS
CT2
VP2
OPN11
OPN12
Z
Y
X

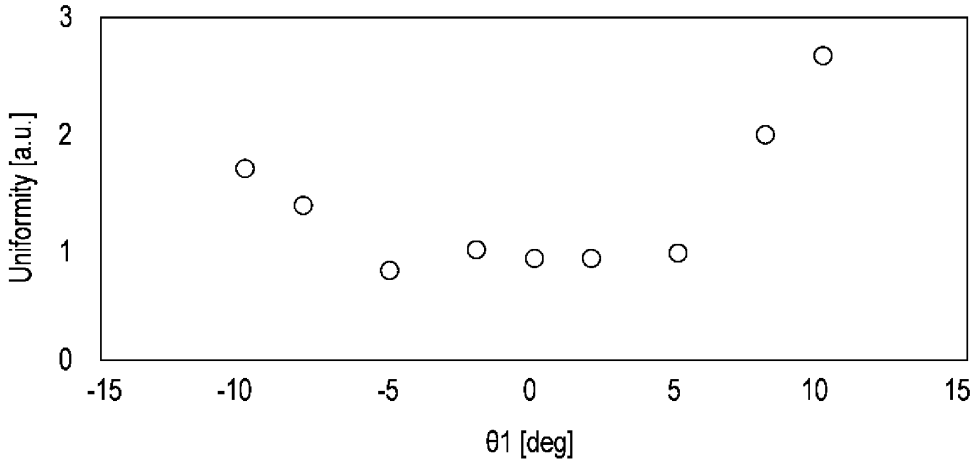
[図6]


131
VV1
θ1'
VV2
132
θ2'
M1
H1
OPN21
S1
M2
H2
OPN22
S2
VP1
HS
S
113
Z
X
Y

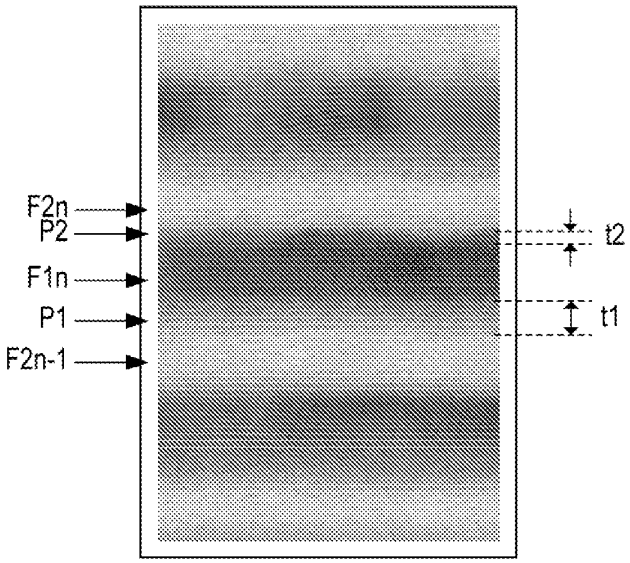
[図7]


Contamination [a.u.]
10
8
6
4
2
0
-15
-10
-5
0
5
10
15
θ1,θ2 [deg]
Mo
Si

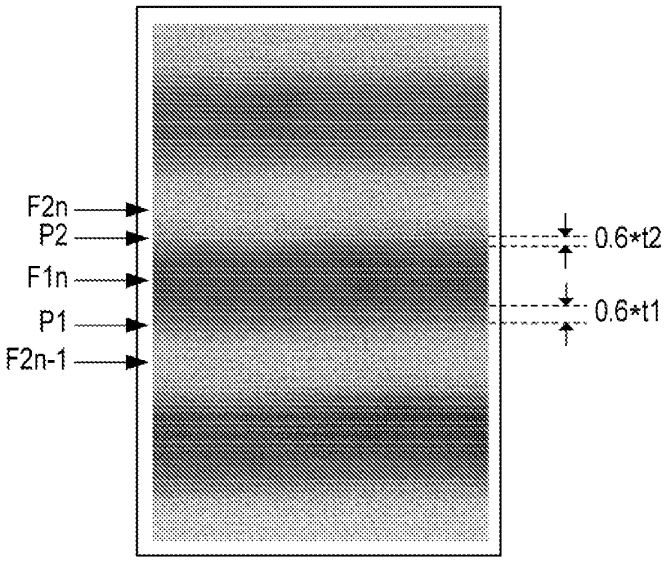
[図8]


Uniformity [a.u.]
3
2
1
0
-15
-10
-5
0
5
10
15
θ1 [deg]

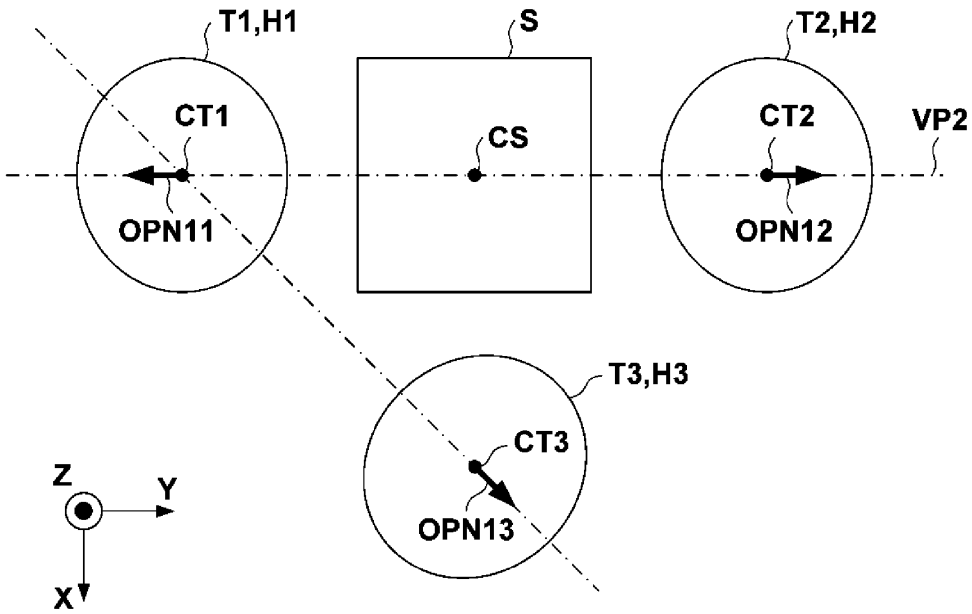
[図9A]



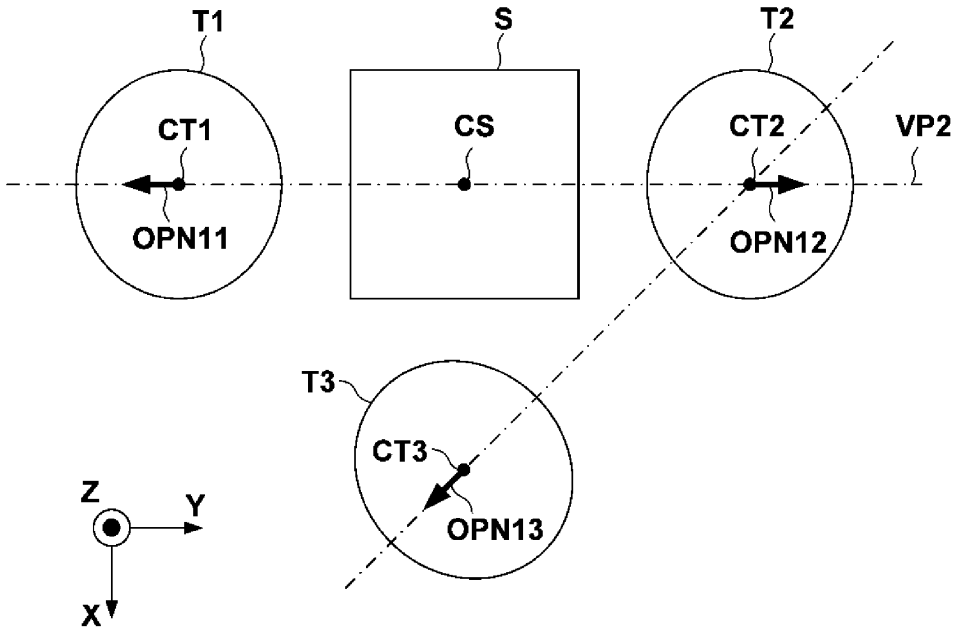
[図9B]



[図10]



[図11]



[図12]

